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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/733,305	12/12/2003	Suk Won Choi	054358-5137	7327
9629 7590 05/12/2008 MORGAN LEWIS & BOCKIUS LLP 1111 PENNSYLVANIA AVENUE NW WASHINGTON, DC 20004				
EXAMINER				
BRIGGS, NATHANIEL R				
ART UNIT		PAPER NUMBER		
2871				
MAIL DATE		DELIVERY MODE		
05/12/2008		PAPER		

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

Office Action Summary

Application No.

10/733,305

Applicant(s)

CHOI ET AL.

Examiner

NATHANAE L. BRIGGS

Art Unit

2871

Period for Reply -- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

Status

- 1) ☒ Responsive to communication(s) filed on 15 February 2008.
- 2a) ☐ This action is **FINAL**. 2b) ☒ This action is non-final.
- 3) ☐ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

Disposition of Claims

- 4) ☒ Claim(s) 1, 4-8 and 14-19 is/are pending in the application.
- 4a) Of the above claim(s) _____ is/are withdrawn from consideration.
- 5) ☐ Claim(s) _____ is/are allowed.
- 6) ☒ Claim(s) 1, 4-8, and 14-19 is/are rejected.
- 7) ☐ Claim(s) _____ is/are objected to.
- 8) ☐ Claim(s) _____ are subject to restriction and/or election requirement.

Application Papers

- 9) ☐ The specification is objected to by the Examiner.
- 10) ☐ The drawing(s) filed on _____ is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).
- 11) ☐ The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

Priority under 35 U.S.C. § 119

- 12) ☐ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
- a) ☐ All b) ☐ Some * c) ☐ None of:
1. ☐ Certified copies of the priority documents have been received.
 2. ☐ Certified copies of the priority documents have been received in Application No. _____.
 3. ☐ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

* See the attached detailed Office action for a list of the certified copies not received.

Attachment(s)

- 1) ☒ Notice of References Cited (PTO-892)
- 2) ☐ Notice of Draftsperson's Patent Drawing Review (PTO-948)
- 3) ☐ Information Disclosure Statement(s) (PTO/S508)
Paper No(s)/Mail Date _____
- 4) ☐ Interview Summary (PTO-413)
Paper No(s)/Mail Date _____
- 5) ☐ Notice of Informal Patent Application
- 6) ☐ Other: _____

DETAILED ACTION

Continued Examination Under 37 CFR 1.114

1. A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after final rejection. Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, the finality of the previous Office action has been withdrawn pursuant to 37 CFR 1.114. Applicant's submission filed on 15 February 2008 has been entered.

Response to Arguments

2. Applicant's arguments with respect to claims 1, 4-8, and 14-19 have been considered but are moot in view of the new ground(s) of rejection.

Claim Rejections - 35 USC § 103

3. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negated by the manner in which the invention was made.

4. **Claims 1, 4-8, and 14-19 are rejected under 35 U.S.C. 103(a) as being unpatentable over Tanuma et al. (US 5,917,569) in view of Takato et al. (US 6,445,434).**

5. Regarding claim 1, Tanuma discloses an aligning method of an LCD (see figures 11(a), 11(b), and 17(a) - 19, for instance), comprising steps of: disposing a first mask (23) and a second mask (24), each of which has opening regions and blocking regions

arranged in alternating fashion in vertical direction and horizontal direction corresponding to liquid crystal cells (13) of the LCD; and injecting a liquid crystal material within a the liquid crystal panel (column 7, lines 31-35); arranging the first mask on a first alignment film (25B) formed on an upper plate of the liquid crystal panel (12); rubbing the first alignment film (25B) of the upper plate (12) through the first mask (23); arranging the second mask (24) on a second alignment film (25A) formed on a lower plate (11) of the liquid crystal panel; and rubbing the second alignment film (25A) of the lower plate (11) in the same direction (column 25, lines 32-42) as the rubbing direction of the alignment film of the upper plate through the second mask (24, column 25, lines 32-42), wherein the opening regions of the first mask (23) corresponds to the blocking regions of the second mask (24) respectively, and the blocking regions of the first mask (23) corresponds to the opening regions of the second mask (24) respectively; wherein each of the opening regions is substantially the same area as a liquid crystal cell (13), the liquid crystal cell corresponding to an area of a pixel electrode (13); and wherein after the upper and lower plates are assembled, the first (25B) and second (25A) alignment films are aligned in opposite directions each other (since same-directional and opposite-directional rubbing occurs on each alignment layer). However, Tanuma does not expressly disclose wherein the liquid crystal material is ferroelectric.

6. Regarding claim 1, Takato discloses a ferroelectric LCD (see figures 1 and 2, for instance), having a similar mask and rubbing process for manufacturing the alignment layer (column 2, lines 15-21; see mask structure in figure 17), wherein the liquid crystal layer is ferroelectric (column 11, lines 15-24).

7. It would have been obvious to one of ordinary skill in the art at the time the invention was made to use ferroelectric liquid crystal material as Takato in the LCD of Tanuma. The motivation for doing so would have been to use an analogous and conventional technology to obtain high speed response, as taught by Takato (column 11, lines 15-24). Claim 1 is therefore unpatentable.

8. Regarding claim 4, Tanuma in view of Takato discloses the aligning method according to claim 1 (see Tanuma 11(a), 11(b), and 17(a) - 19, for instance), and Tanuma further discloses the step of disposing a first mask and a second mask (23, 24), further comprising the steps of: arranging the first mask having opening regions on a first alignment film (25B) formed on an upper plate of the liquid crystal panel; photo-exposing the first alignment film of the upper plate with an ultraviolet ray through the first mask; arranging the second mask (24) having opening regions on a second alignment film (25A) formed on the lower plate of the liquid crystal panel; and photo-exposing the second alignment film of the lower plate through the second mask. Claim 4 is therefore unpatentable.

9. Regarding claim 5, Tanuma in view of Takato discloses the aligning method according to claim 4 (see Tanuma 11(a), 11(b), and 17(a) - 19, for instance), and Tanuma further discloses wherein each of the opening regions openings is substantially the same area size as a liquid crystal cell (13). Claim 5 is therefore unpatentable.

10. Regarding claim 6, Tanuma in view of Takato discloses the aligning method according to claim 4 (see Tanuma 11(a), 11(b), and 17(a) - 19, for instance), and

Tanuma further discloses wherein the opening -and blocking regions in the first and the second masks are arranged in an alternating fashion. Claim 6 is therefore unpatentable.

11. Regarding claim 8, Tanuma discloses an aligning method of an LCD (see figures 11(a), 11(b), and 17(a) - 19, for instance), comprising steps of: aligning an upper plate (12) of a liquid crystal panel by using a first mask (23) having a first plurality of opening regions patterned thereon; rubbing a first alignment film (25B) of the upper plate (12) through the first mask (23) along a first direction; aligning a lower plate (11) of the liquid crystal panel by using a second mask (24) having a second plurality of opening regions patterned thereon; rubbing a second alignment film (25B) of the lower plate (11) through the second mask (24) along the first direction, assembling the upper and lower plates (12, 11) of the liquid crystal panel such that the first and second alignment films are aligned in opposite directions to each other (since same-directional and opposite-directional rubbing occurs on each alignment layer; column 20, lines 20-35); and injecting a liquid crystal material (column 7, lines 31-35) between the assembled the upper and the lower plates (12, 11) of the liquid crystal panel, wherein the opening regions of the first mask (23) corresponds to blocking regions of the second mask (24) respectively, and the opening regions of the second mask (24) corresponds to blocking regions of the first mask (23) respectively; and wherein each of opening regions openings of the first and second masks is substantially the same area as a liquid crystal cell (13), the liquid crystal cell corresponding to an area of a pixel electrode (13). However, Tanuma does not expressly disclose wherein the liquid crystal material is ferroelectric.

12. Regarding claim 8, Takato discloses a ferroelectric LCD (see figures 1 and 2, for instance), having a similar mask and rubbing process for manufacturing the alignment layer (column 2, lines 15-21; see mask structure in figure 17), wherein the liquid crystal layer is ferroelectric (column 11, lines 15-24).

13. It would have been obvious to one of ordinary skill in the art at the time the invention was made to use ferroelectric liquid crystal material as Takato in the LCD of Tanuma. The motivation for doing so would have been to use an analogous and conventional technology to obtain high speed response, as taught by Takato (column 11, lines 15-24). Claim 8 is therefore unpatentable.

14. Regarding claim 14, Tanuma in view of Takato discloses the aligning method according to claim 1 (see Tanuma 11(a), 11(b), and 17(a) - 19, for instance), and Tanuma further discloses wherein the liquid crystal panel has first regions corresponding to the opening regions of the first mask (23) and second regions corresponding to the opening regions of the second mask (24), the first regions and the second regions are respectively aligned in opposite directions. Claim 14 is therefore unpatentable.

15. Regarding claim 15, Tanuma in view of Takato discloses the aligning method according to claim 8 (see Tanuma 11(a), 11(b), and 17(a) - 19, for instance), and Tanuma further discloses wherein the liquid crystal panel has first regions corresponding to the opening regions of the first mask (23) and second regions corresponding to the opening regions of the second mask (24), the first regions and the

second regions are respectively aligned in opposite directions. Claim 15 is therefore unpatentable.

16. Regarding claim 16, Tanuma in view of Takato discloses the aligning method according to claim 14 (see Tanuma 11(a), 11(b), and 17(a) - 19, for instance), wherein the first regions and the second regions are alternately arranged in a vertical and horizontal direction of the liquid crystal panel. Claim 16 is therefore unpatentable.

17. Regarding claim 17, Tanuma in view of Takato discloses the aligning method according to claim 15 (see Tanuma 11(a), 11(b), and 17(a) - 19, for instance), wherein the first regions and the second regions are alternately arranged in a vertical and horizontal direction of the liquid crystal panel. Claim 17 is therefore unpatentable.

18. Regarding claim 18, Tanuma in view of Takato discloses the aligning method according to claim 14 (see Tanuma 11(a), 11(b), and 17(a) - 19, for instance), wherein the first regions and the second regions are substantially the same area as the liquid crystal cell (13) of the liquid crystal panel. Claim 18 is therefore unpatentable.

19. Regarding claim 19, Tanuma in view of Takato discloses the aligning method according to claim 15 (see Tanuma 11(a), 11(b), and 17(a) - 19, for instance), wherein the first regions and the second regions are substantially the same area as the liquid crystal cell (13) of the liquid crystal panel. Claim 19 is therefore unpatentable.

20. Claim 7 is rejected under 35 U.S.C. 103(a) as being unpatentable over Tanuma et al. (US 5,917,569) in view of Takato et al. (US 6,445,434) as applied to claim 4 above, and further in view of Ishii (US 6,133,974).

21. Regarding claim 7, Tanuma in view of Takato discloses the aligning method according to claim 4 (see Tanuma 11(a), 11(b), and 17(a) - 19, for instance). However, Tanuma in view of Takato does not disclose steps of: phase-transiting the ferroelectric liquid crystal material within the liquid crystal panel from an isotropic phase to a nematic phase by lowering temperature of the liquid crystal panel; and phase-transiting the ferroelectric liquid crystal within the liquid crystal panel from the nematic phase to a smectic C phase by further lowering the temperature of the liquid crystal panel.

22. Regarding claim 7, Ishii an aligning method (see figures 13 and 19, for instance), having steps of phase-transitioning the FLC material within the LCD from isotropic to nematic phase by lowering temperature of the LCD (column 39, lines 44-51); and phase-transitioning the FLC material within the LCD from a nematic phase to a smectic C phase by further lowering the temperature of the LCD (column 3, lines 41-50; column 39, lines 60-62).

23. It would have been obvious to one of ordinary skill in the art at the time of the invention to use the rubbing directions of Ishii in the FLC of Tanuma in view of Takato. The motivation for doing so would have been to gain improved viewing angle dependency, as taught by Ishii (column 6, lines 13-15; column 41, lines 49-54). Claim 7 is therefore unpatentable.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to NATHANAEL R. BRIGGS whose telephone number is

Art Unit: 2871

(571)272-8992. The examiner can normally be reached on 9 AM - 5:30 PM Monday through Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Nelms can be reached on (571) 272-1787. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Nathanael Briggs – 5/7/2008

/Andrew Schechter/
Primary Examiner, Art Unit 2871